

Modules of the 2025 course

| Topics covered | No | Lecture/Date |
|---|----|--------------|
| VAT Photo polymerization (history) – DLP printer – light engine – part I | 5 | 20.03.2025 |
| DLP printer – chemical components in a photoresin – role of oxygen – CLIP method– part II | 6 | 27.03.2025 |
| Tomographic Volumetric Additive Manufacturing (TVAM): principles and applications | 7 | 03.04.2025 |
| Two photon Polymerization : nanoscale printing | 8 | 10.04.2025 |
| Two photon Polymerization : applications | 9 | 17.04.2025 |
| EASTER BREAK | | 22.04.2025 |
| Prof. Paul Dalton, University of Oregon: Met Electro Writing (nanoscale) | 10 | 1.05.2025 |
| Gari Arutinov, Holst Center for AM: Mass transfer of microcomponents | 11 | 08.05.2025 |
| Julian Schneider: Scrona | 12 | 15.05.2025 |
| Patrizia Richner: Sonova (hearing aids). // | 13 | 22.05.2025 |
| Design Competition | | |

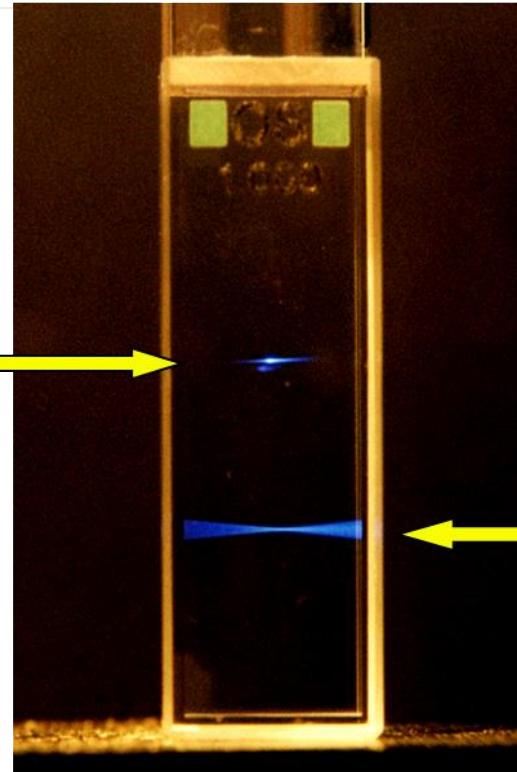
QUIZZ #2

2 Photon printing



Recap: Two-photon absorption

Excitation by two photons is confined to a volume very close to focus where intensity is highest, giving rise to *pinpoint 3D resolution*



Excitation by one photon results in absorption along the entire path of the laser beam in the cuvette.

Two-photon absorption

Example: 2 photons infrared of wavelength $\lambda_1 = 800 \text{ nm}$ ($\nu_1 = c/\lambda_1$) have a combined energy of $E = 2h\nu_1$ and can produce absorption at $\nu_2 = 2\nu_1$ ($\lambda_2 = c/\nu_2 = \frac{c}{2\nu_1} = \frac{1}{2}\lambda_1$)

$\frac{dN_1}{dt}$ of molecules in excited state
linear absorption $\propto \frac{1}{m}$

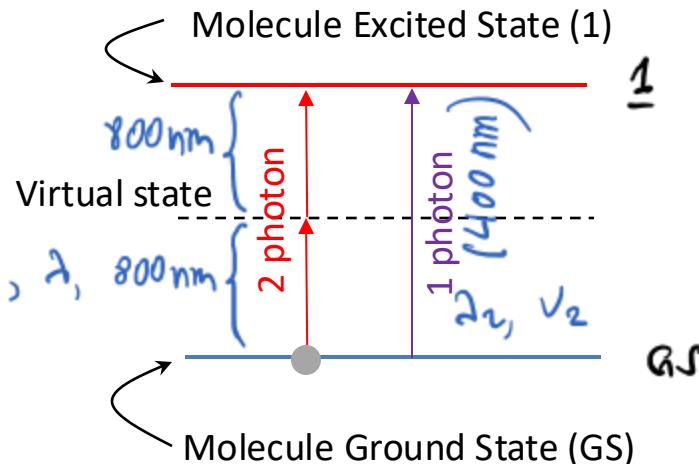
$$\frac{dN_1}{dt}, \text{ one photon} = +\sigma N_{GS} \cdot \frac{I}{h\nu}$$

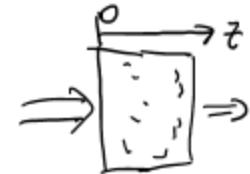
one photon cross-section $[m^2]$

$$\frac{dN_1}{dt}, \text{ two photon} = \frac{1}{2} \delta N_{GS} \cdot \frac{I^2}{(h\nu)^2} \cdot \frac{\beta}{2} = \frac{1}{2} S \frac{N_{GS}}{h\nu} \frac{\nu_1}{I^2}$$

two-photon cross-section $[m^4 \cdot s]$

$1 \text{ GJ} = 10^{-50} [\text{cm}^4 \cdot \text{s}]$





In terms of absorption for the light intensity

Single photon $\frac{dI(z)}{dz} = -\alpha \cdot I(z) \Rightarrow I(z) = I(0) e^{-\alpha z}$

$$\lambda_1 = 400 \text{ nm}$$

Two photon $\frac{dI(z)}{dz} = -\alpha \cdot I(z) - \beta I^2(z)$

$$\lambda_2 = 800 \text{ nm}$$

Estimation of the light intensity required to have a two-photon absorption of similar magnitude to single photon absorption:

$$\alpha I \approx \beta I^2 \Rightarrow \alpha = \beta I \Rightarrow I = \frac{\alpha}{\beta}$$

$$I = \frac{2 \sigma}{\delta} \cdot h \lambda = 2 \frac{\sigma}{\delta} h \frac{c}{\lambda}$$

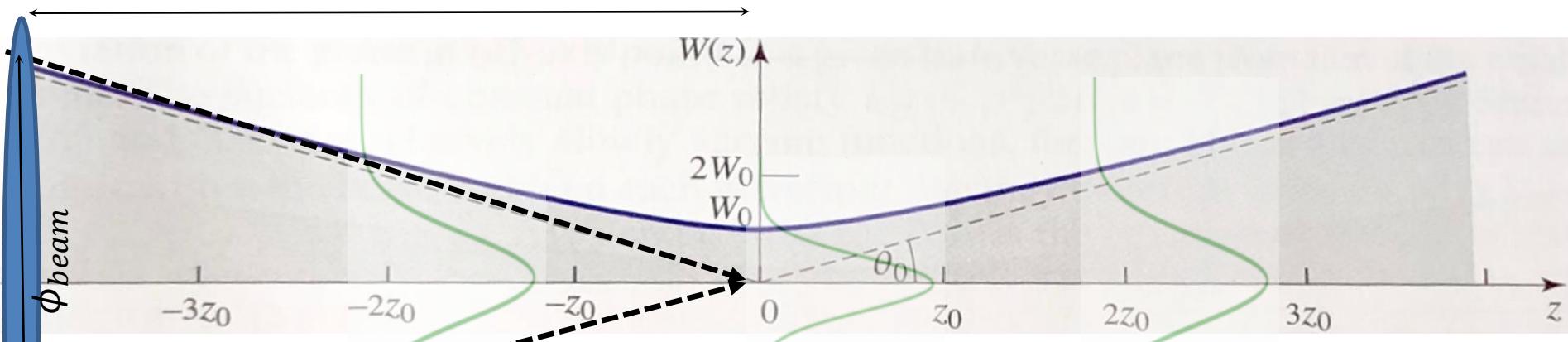
Typ. Values $\sigma = 10^{-16} \text{ cm}^2$

Assume 1 photon

~~Assumption~~ $\delta = 1000 \text{ GP} = 1000 \cdot 10^{-50} \text{ cm}^4 \text{ J}$

$I \approx 50 \cdot 10^9 \frac{\text{W}}{\text{mm}^2} = 50 \text{ GW/mm}^2$

Recap: Two-photon absorption



$$I = \frac{P}{\pi W_0^2} \Rightarrow P = I \cdot (\pi W_0^2) = 50.6 \text{ W/mm}^2 \cdot 215 \text{ kW}$$

$$W_0 = 0.66 \cdot \frac{\lambda}{NA} = 1.17 \mu\text{m}$$

$\backslash 0.2$

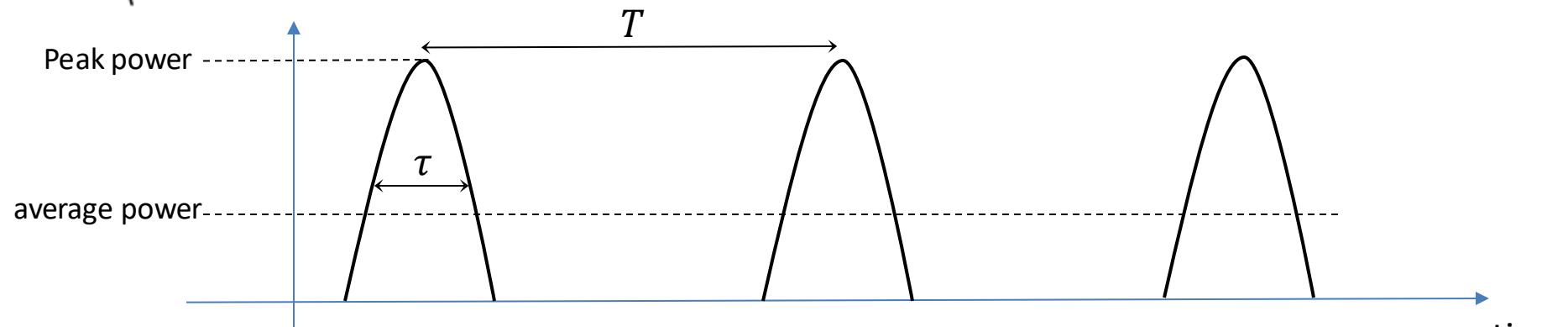
Two-photon absorption

215

How to generate a laser power of ~~800~~ kW ?

Ans: pulsed laser

Ans: pulsed power



$$P_{\text{average}} = \frac{\text{average laser energy}}{\text{time}} = \frac{\# \text{ pulses} \cdot \text{energy/pulse}}{\text{time}} = 1 \frac{\text{energy/pulse}}{\frac{T}{\tau}}$$

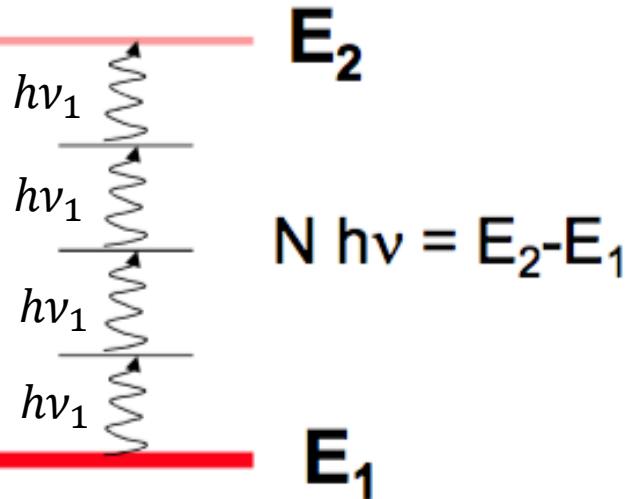
$$P_{\text{peak}} = \frac{\text{energy/pulse}}{\tau} = P_{\text{average}} \cdot \frac{T}{\tau}$$

Multi-photon absorption

A material is transparent at a wavelength of λ_1 ($\lambda_1 \cdot \nu_1 = c$) (i.e frequency $\nu_1 = C/\lambda_1$) but can become absorptive at very high optical peak powers

When $N=2$, the process is called Two photon absorption (TPA)

Multi-photon process



Two-photon absorption

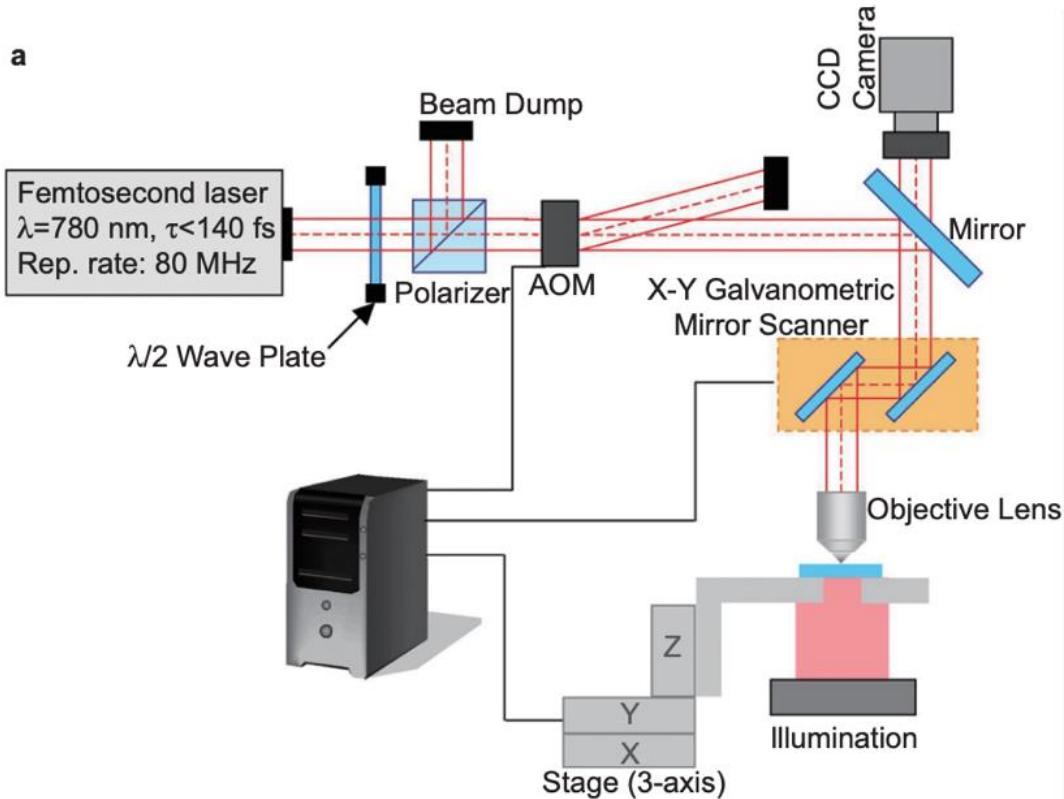
| | τ | $P_{average}$ | $1/T$ | |
|-----------------------------|------------------------|---|------------------------|--------------|
| FemtoFiber smart 780 | $785 \pm 5 \text{ nm}$ | < 100 fs (typ. 80 fs) $100 \cdot 10^{-15} \text{ s}$ | > 120 mW (typ. 140 mW) | 80 MHz 16 |



$$P_{peak} \cdot P_{average} \cdot \frac{1}{\tau} = 0.12 \text{ W} \cdot \frac{1}{10^{-13} \cdot 80 \cdot 10^6} = \underline{\underline{15 \text{ kJ}}}$$

$$N.A \gtrsim \underline{\underline{0.8}}$$

Typical setup for 2-photon polymerization

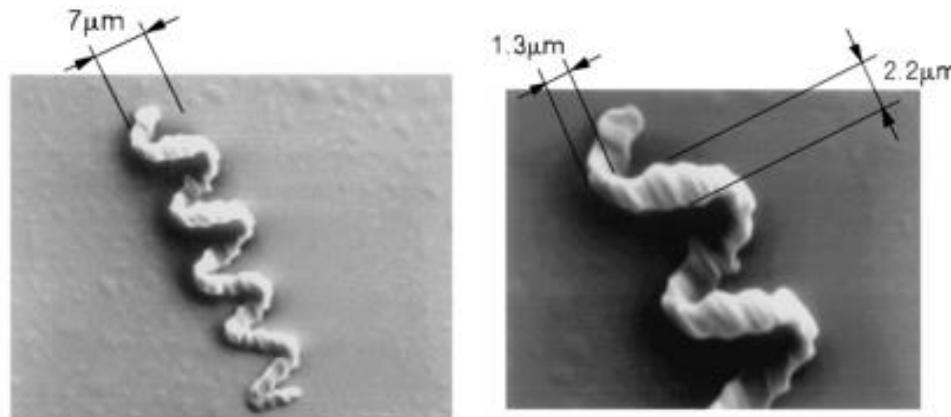


Three-dimensional microfabrication with two-photon-absorbed photopolymerization

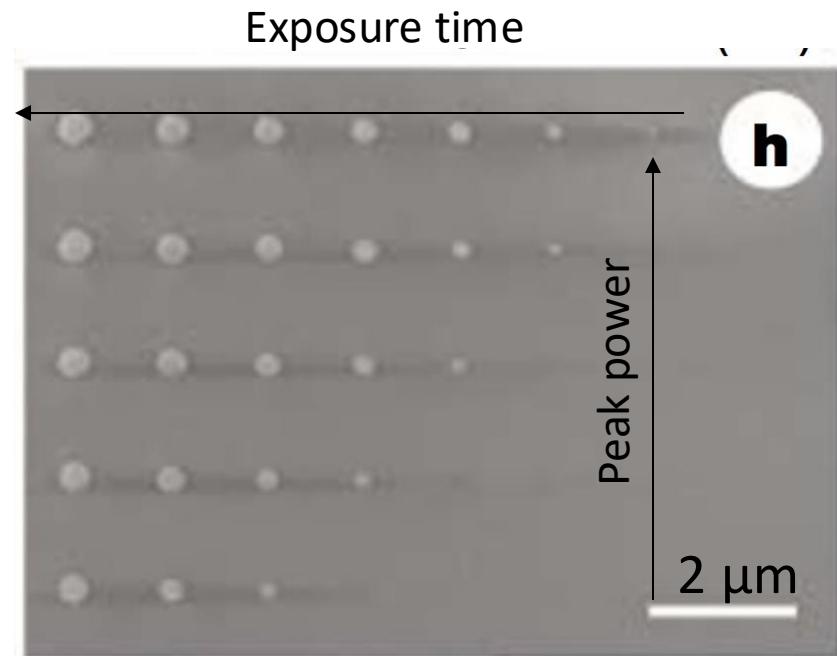
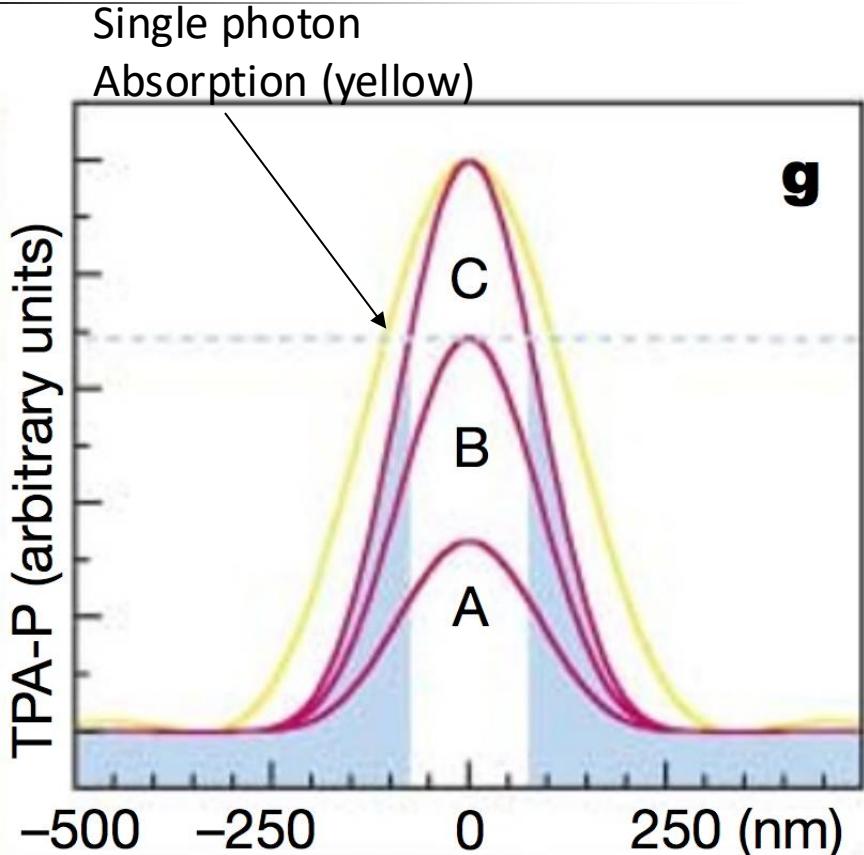
Shoji Maruo, Osamu Nakamura, and Satoshi Kawata

Department of Applied Physics, Osaka University, Suita, Osaka 565, Japan

method. The light source that we used for the two photon absorption was a mode-locked Ti:sapphire laser whose oscillating wavelength, pulse width, repetition rate, and peak power were 790 nm, 200 fs, 76 MHz and 50 kW, respectively. The Ti:sapphire laser was excited by an Ar-ion laser of 8-W average power. The beam of the laser was focused into the resin with an objective lens whose N.A. was 0.85. A stage support



Printed voxel size



Printed voxel size

Energy per pulse: $E_{pulse} = 137 \text{ pJ}$

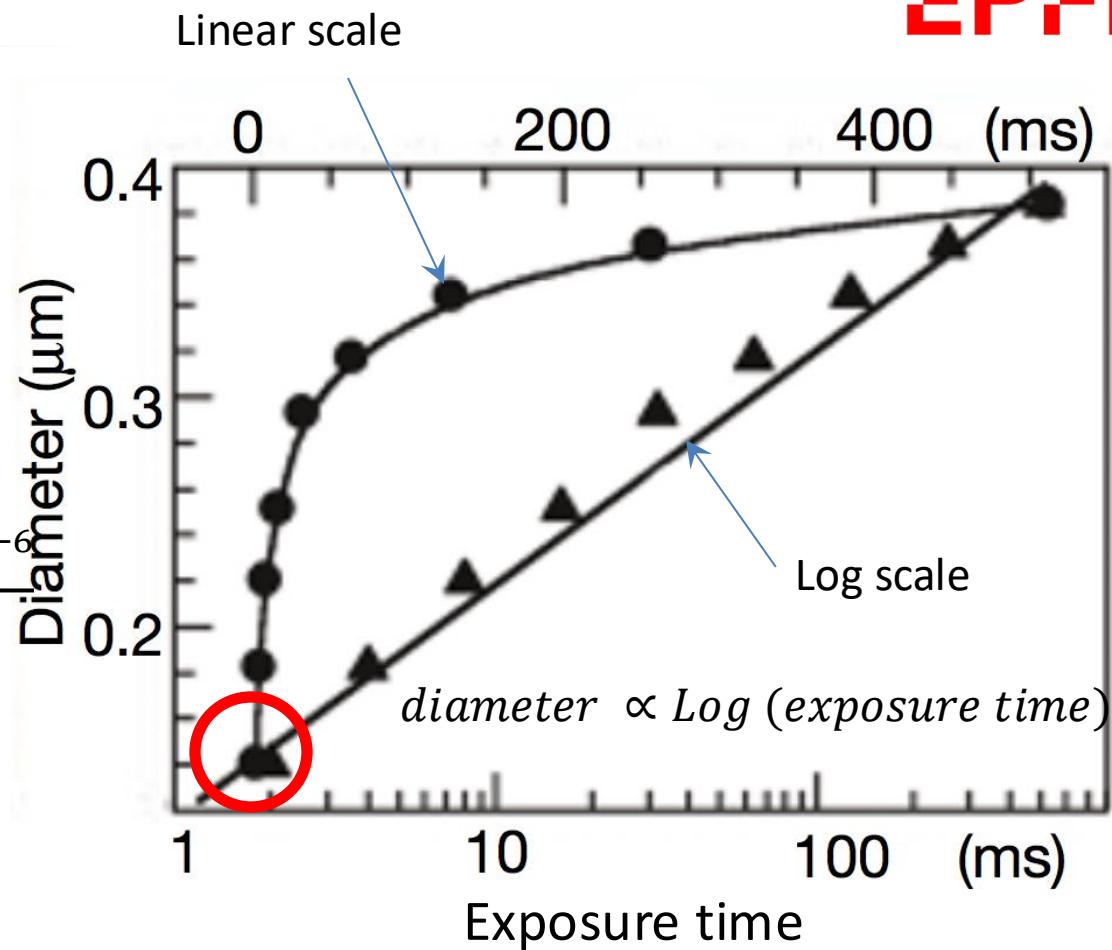
Pulse duration: $\tau = 150$ fs

$$P_{peak} = \frac{E_{pulse}}{\tau} = \frac{137 \cdot 10^{-12}}{150 \cdot 10^{-15}} = 910 \text{ W (10 mW average power)}$$

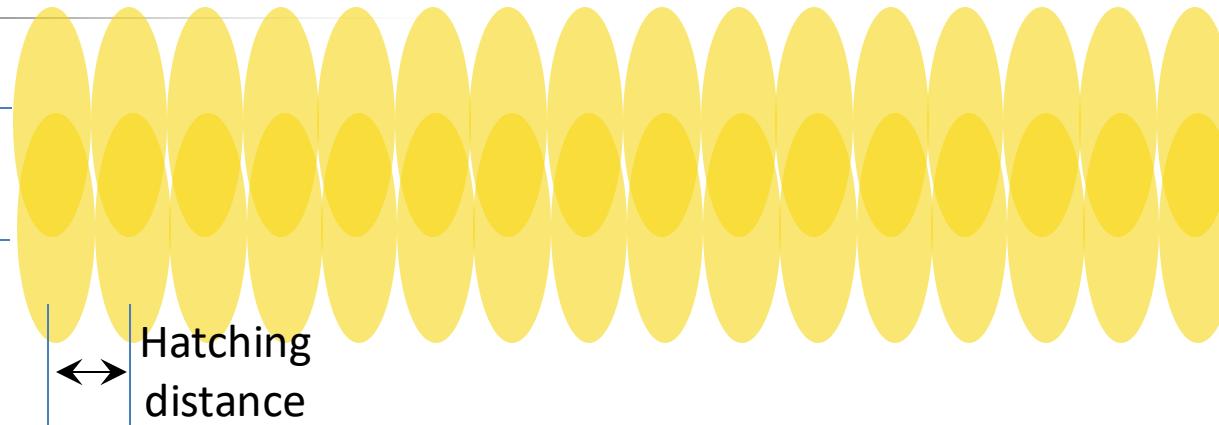
Numerical aperture NA=1.4

$$waist = 0.66 \frac{\lambda}{NA} = \frac{0.66 \cdot 0.8 \cdot 10^{-6}}{1.4} \text{ } \mu\text{m} = 0.37 \text{ } \mu\text{m}$$

$$I = \frac{P_{peak}}{\pi \cdot waist^2} = 2.1 \text{ } GW/mm^2$$



Slicing
distance

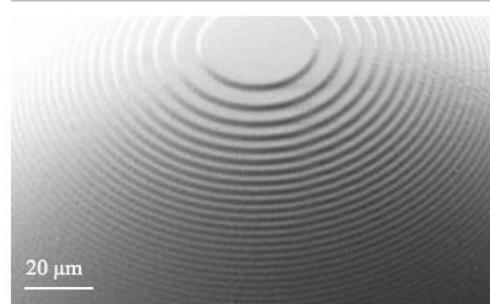
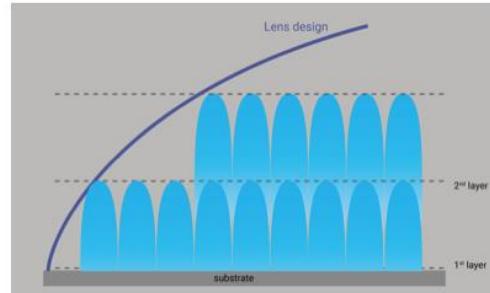


Scanning steps can be smaller to make a
smooth surface

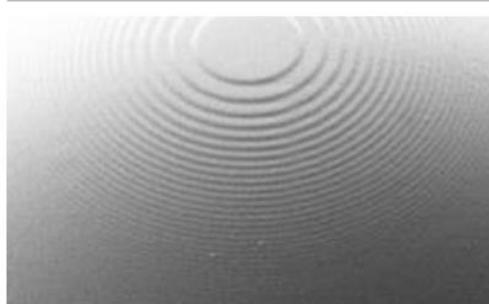
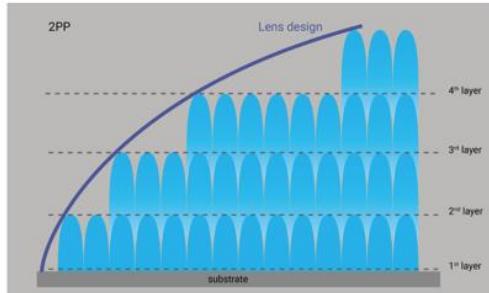




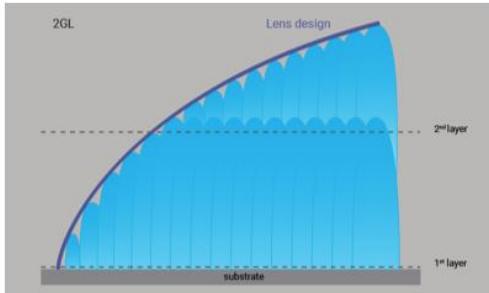
Challenge in high-precision 3D printing Staircasing vs. printing speed



2PP with coarse slicing



2PP with fine slicing



2GL® with coarse slicing

Courtesy of
NanoScribe

Example:

20 x 20 x 20 um

2 ms exposure

Hatching-slicing (x,y,z): 0.15 um.

$$\#points = \frac{20^3}{0.15^3} = 2.4 \text{ million}$$

Exposure time = 1h 20 min

If only the outer shell of the bull is Printed, the number of points can be Reduced.

The authors printed it in 13 minutes

